

Special Topics on Basic EECS I

Design Technology Co-Optimization

Lecture 18

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L18

Physical models

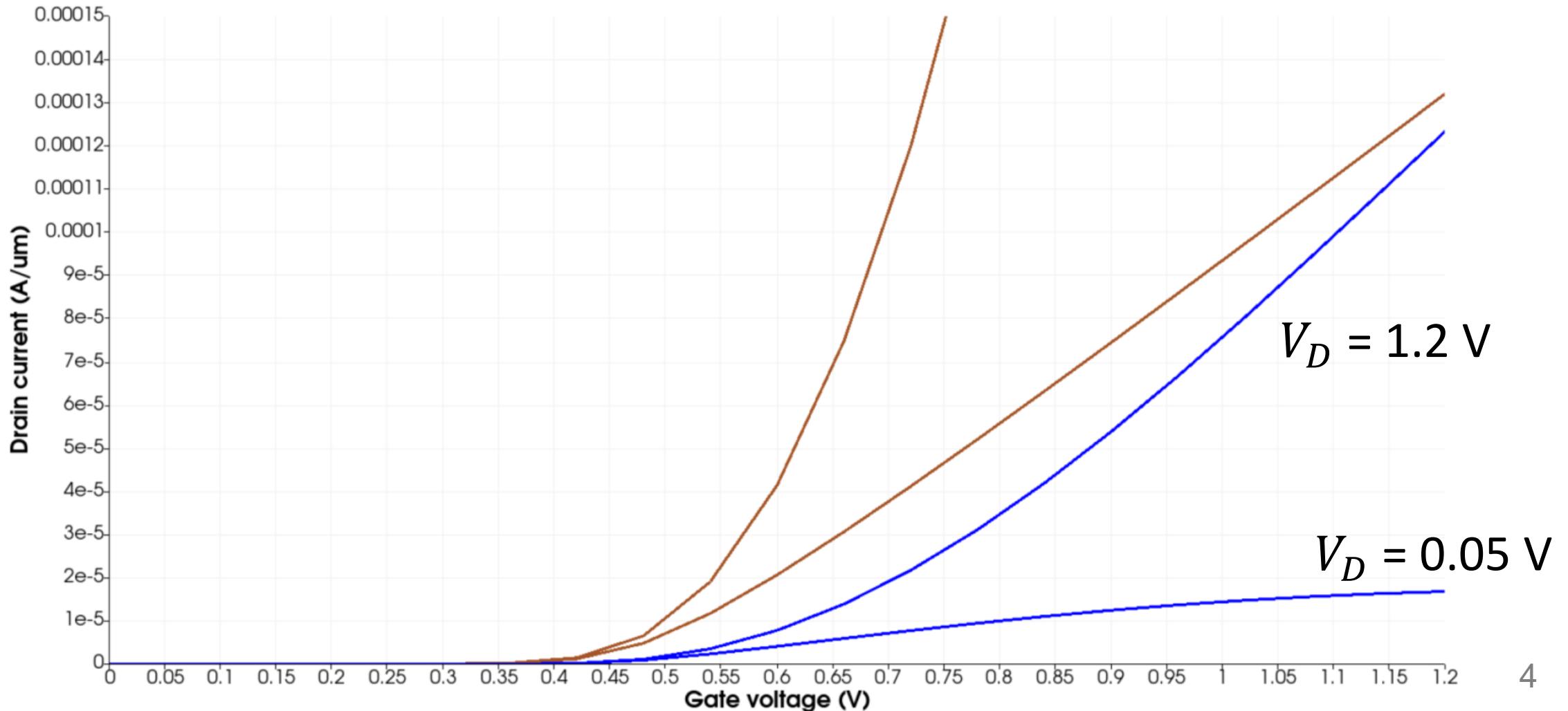
- Of course, we must include physical models.
 - Add the following lines.

```
property (thing="mosfet",model="mobility",mujtaba,canali)  
property (thing="mosfet",model="recombination",srh)
```

- Observe their effects.

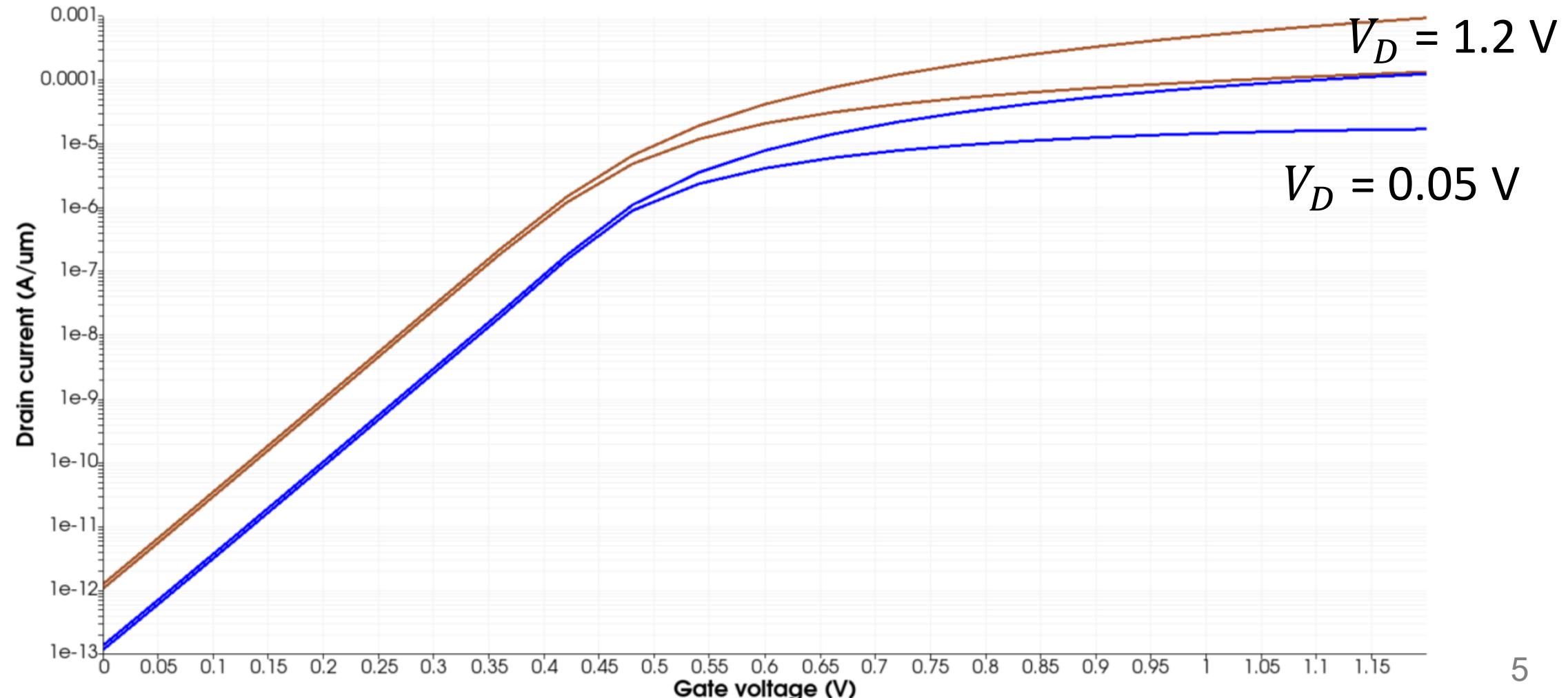
Linear curve

- Significantly reduced current (Blue curves)



Semi-logarithmic curve

- Significantly reduced current (Blue curves)



Ramping the drain voltage up

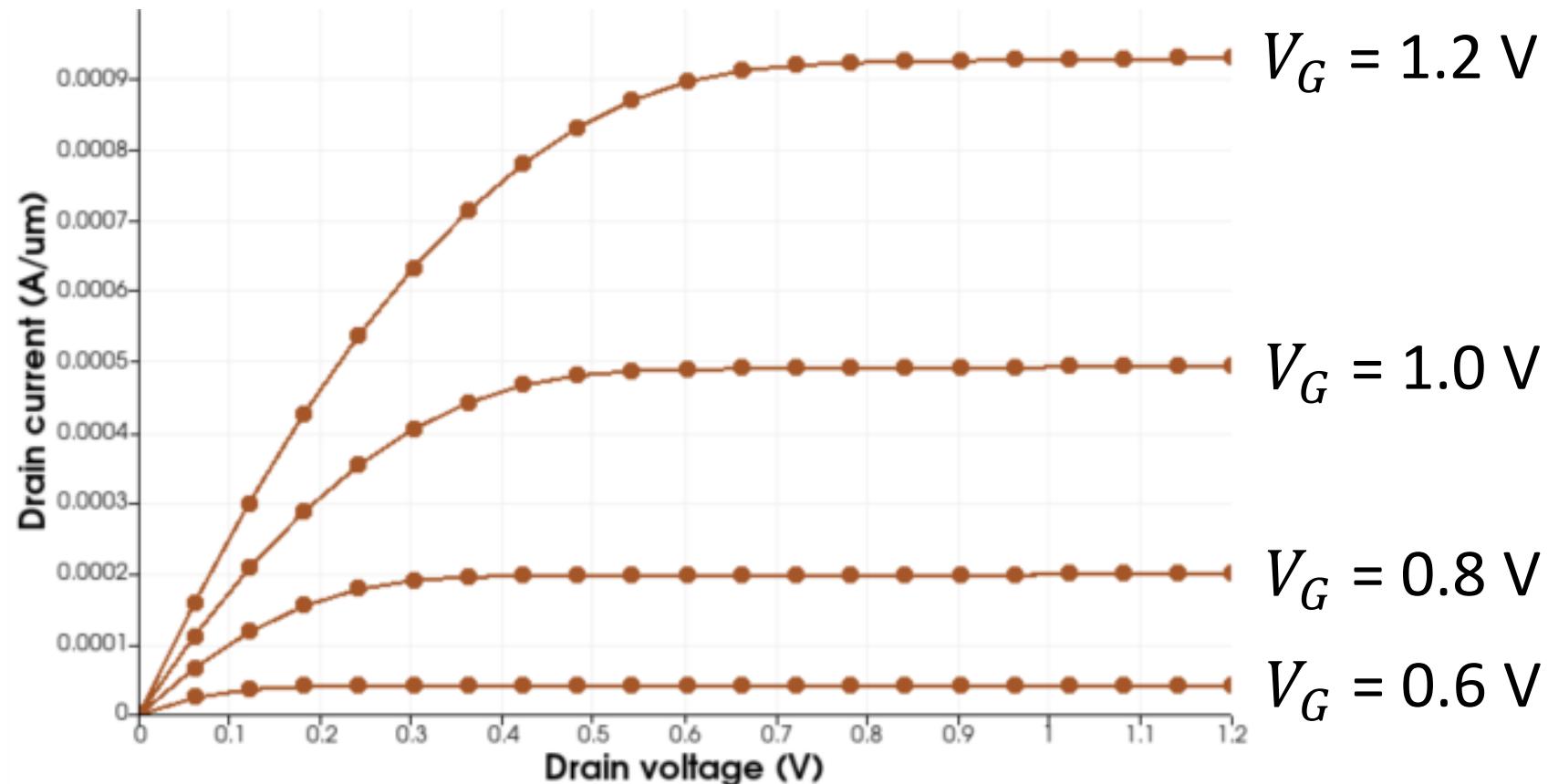
- We need several gate voltages.
 - Select a value and ramp up the gate voltage.
- Increase the drain voltage from 0 V to V_{DD} .

```
solve (law="dclaw",initialstep=0.05,maxstep=0.05,minstep=0.01,dozero,  
      plot,plotprefix="long_dc",cgns,book="output_iv") {  
    goal (thing="vd", quantity="voltage", value=1.2)  
}
```

- Repeat it with other V_G values.

Without physical models

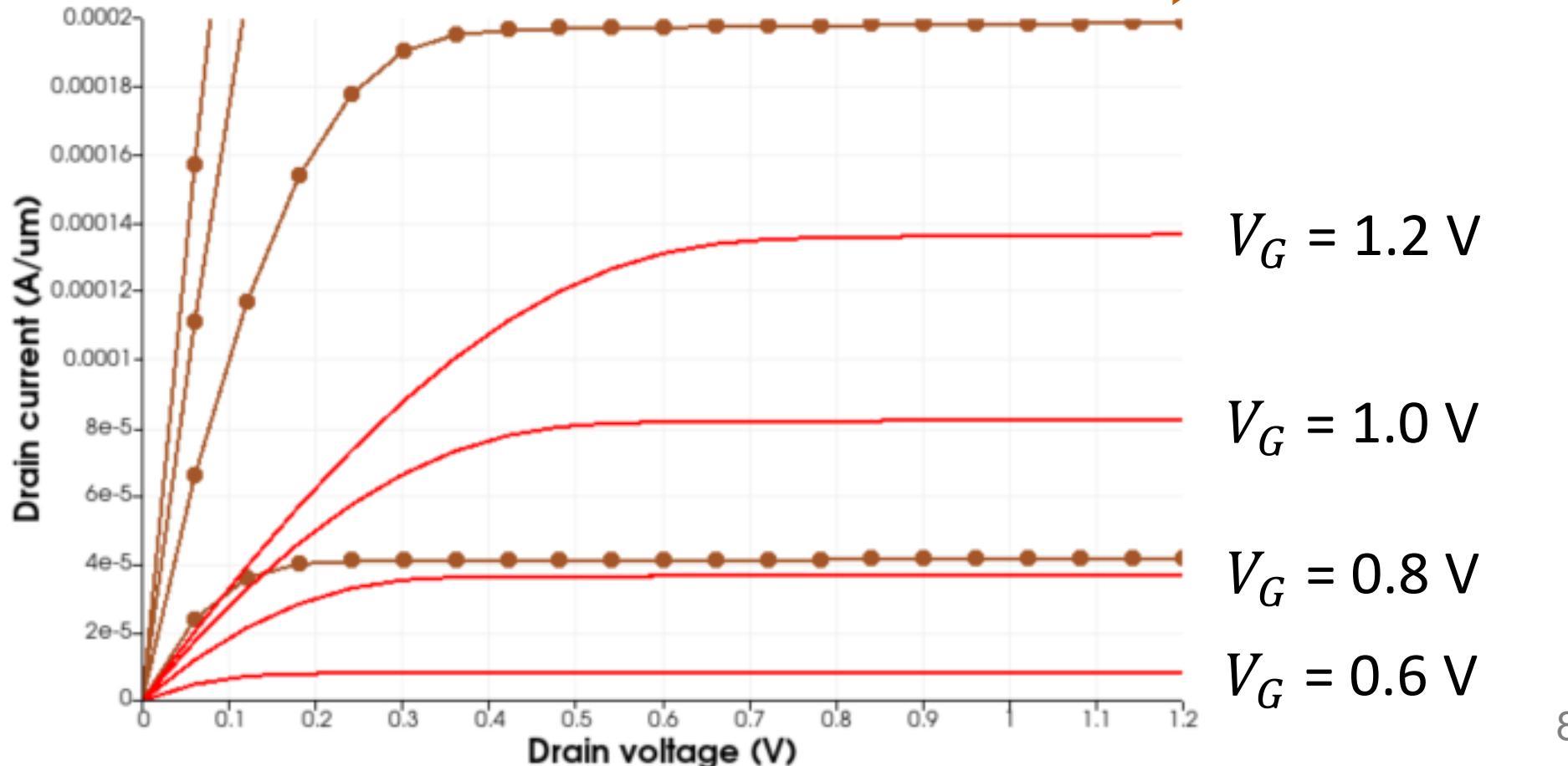
- Results WITHOUT any physical model from $V_G = 0.6 \text{ V}$ to 1.2 V (0.2 V step)



Inversion mobility model

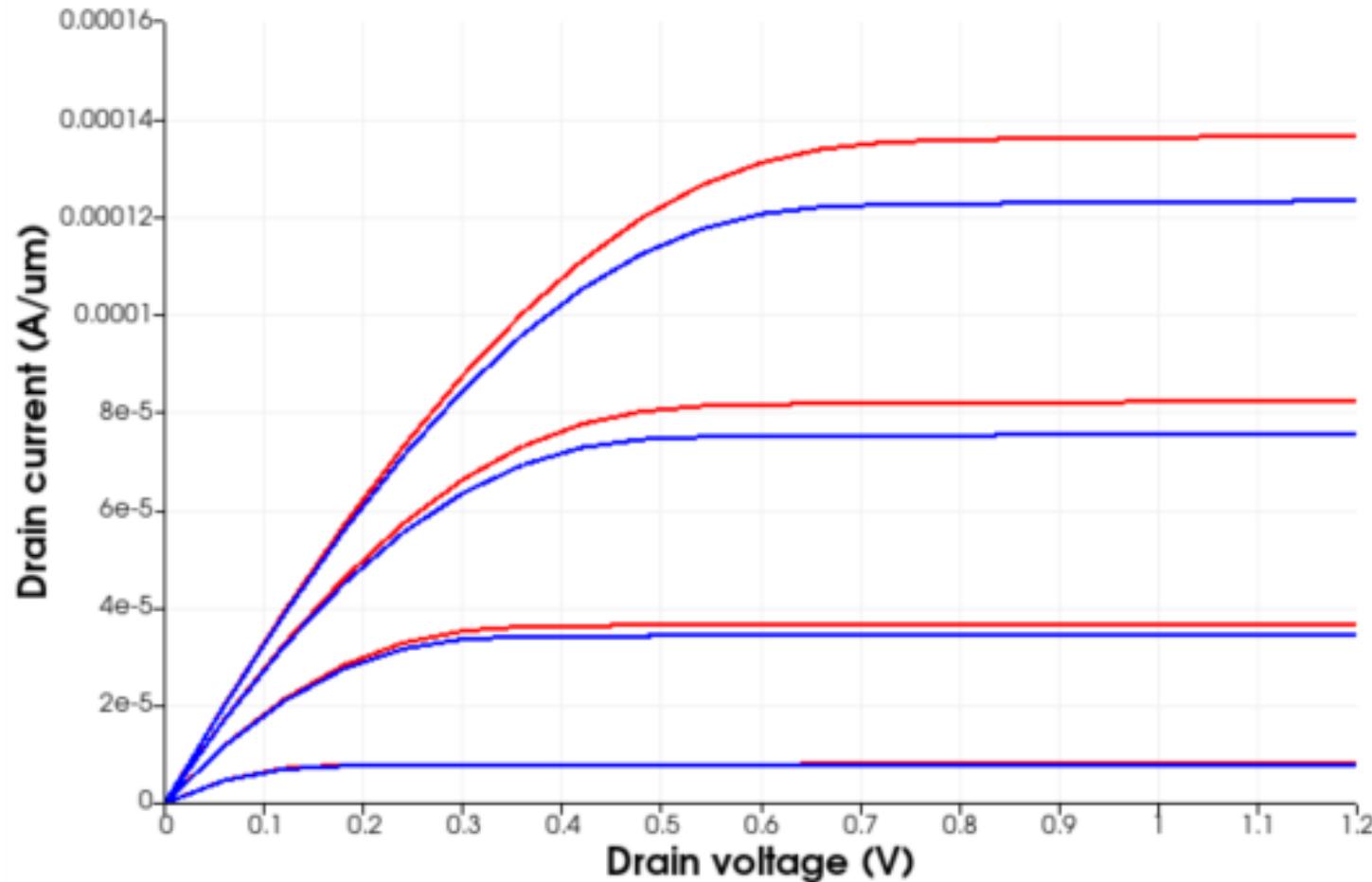
- Results WITH inversion mobility model

- Significantly reduced current (Brown versus red)



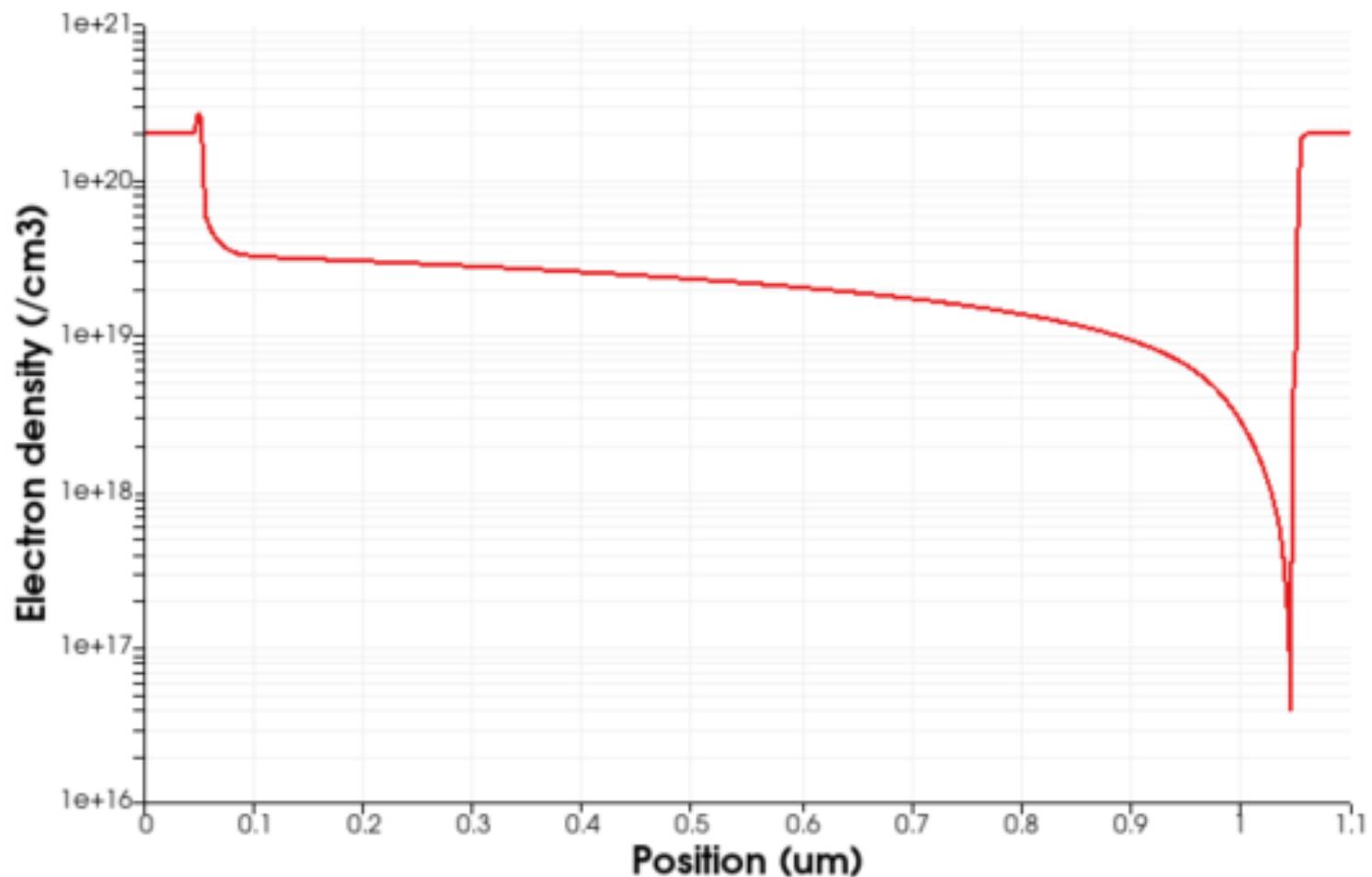
Velocity saturation

- Results WITH inversion mobility model + velocity saturation



Electron density

- Interface carrier density at $V_G = V_D = V_{DD}$

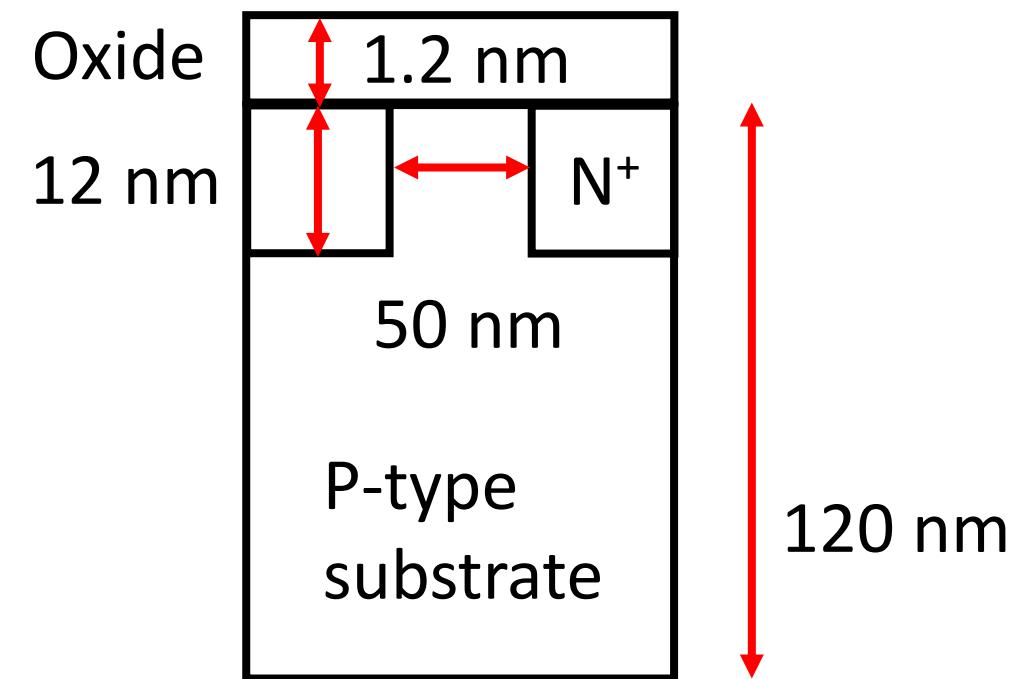


Homework#18

- Due: 08:00 on Nov. 19
- Submit a report through the GIST LMS system.
 - From the input IV characteristics of our long-channel MOSFET, estimate the DIBL. (Of course, you must consider physical models.)

Simulation of a short-channel MOSFET

- Effective oxide thickness of 1.2 nm
 - Gate workfunction of 4.3 eV
 - Substrate doping of $1.5 \times 10^{18} \text{ cm}^{-3}$
 - V_{DD} of 1.2 V
- Channel length of 50 nm
 - 1 nm spacing



Mapmaker

- Input file

- x : Depth
- y : Channel
- z : Width

```
thing (type="mapmaker",name="structure") {
    mapmaker (type="3d",cgns="long.cgns") {
        cuboid (x0=-1.2nm,y0=-550nm,x1=120nm,y1=550nm,z0=0.0,z1=1.0um,nx=102,ny=221,nz=2)
        region (name="semiconductor",material="silicon",ix0=1,ix1=101,iy0=0,iy1=220,iz0=0,iz1=1)
        region (name="insulator", material="oxide", ix0=0,ix1=1, iy0=0,iy1=220,iz0=0,iz1=1)
        doping (region="semiconductor",ix0=1,ix1=101,iy0=0, iy1=220,iz0=0,iz1=1,density=-1.5e18/cm3)
        doping (region="semiconductor",ix0=1,ix1=11, iy0=0, iy1=10, iz0=0,iz1=1,density=2e20/cm3)
        doping (region="semiconductor",ix0=1,ix1=11, iy0=210,iy1=220,iz0=0,iz1=1,density=2e20/cm3)
        contact (name="source",ix0=1, ix1=6, iy0=0, iy1=0, iz0=0,iz1=1)
        contact (name="gate", ix0=0, ix1=0, iy0=10, iy1=210,iz0=0,iz1=1)
        contact (name="drain", ix0=1, ix1=6, iy0=220,iy1=220,iz0=0,iz1=1)
        contact (name="body", ix0=101,ix1=101,iy0=0, iy1=220,iz0=0,iz1=1)
    }
}
```

Short and long structures

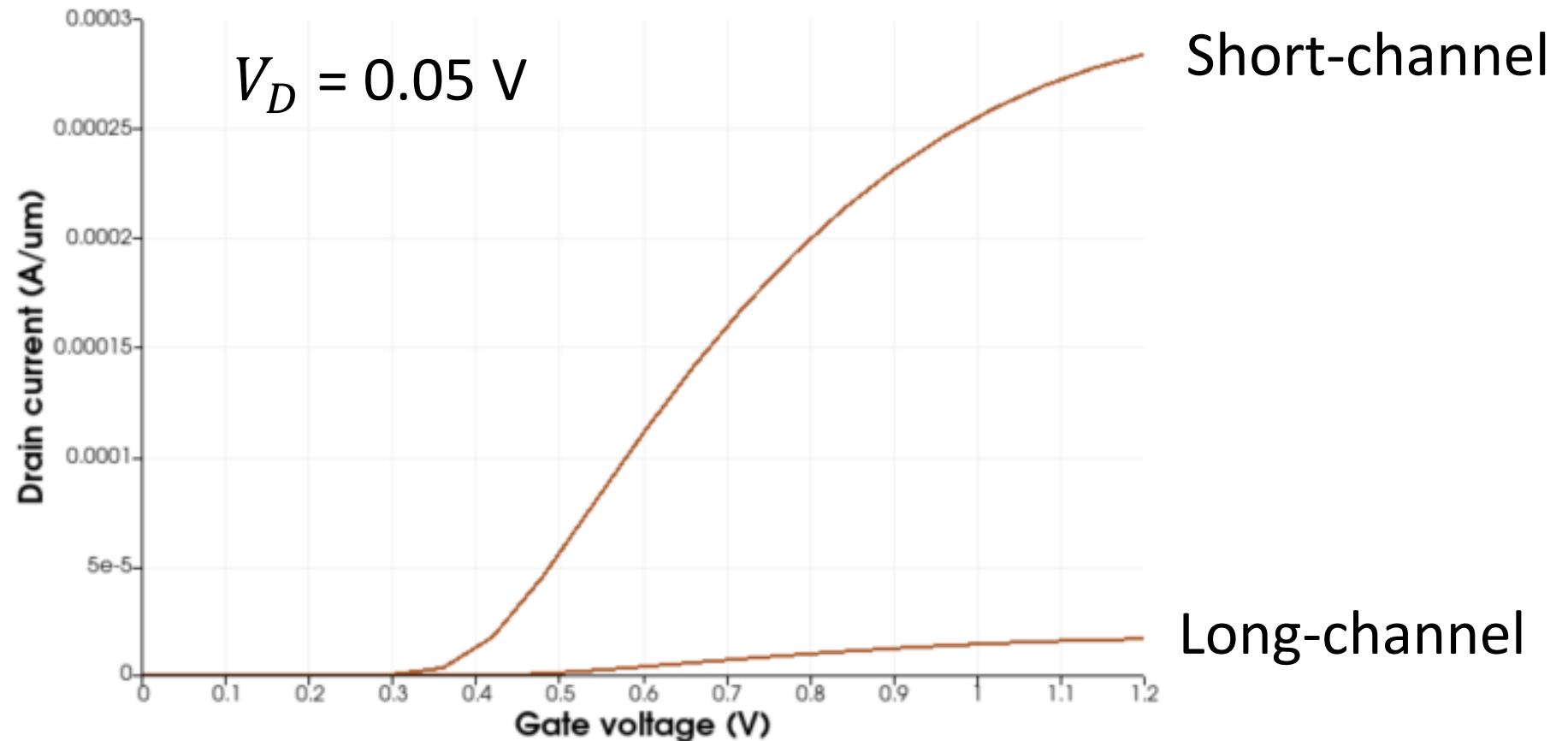
- Drawn in the same scale



Input characteristics

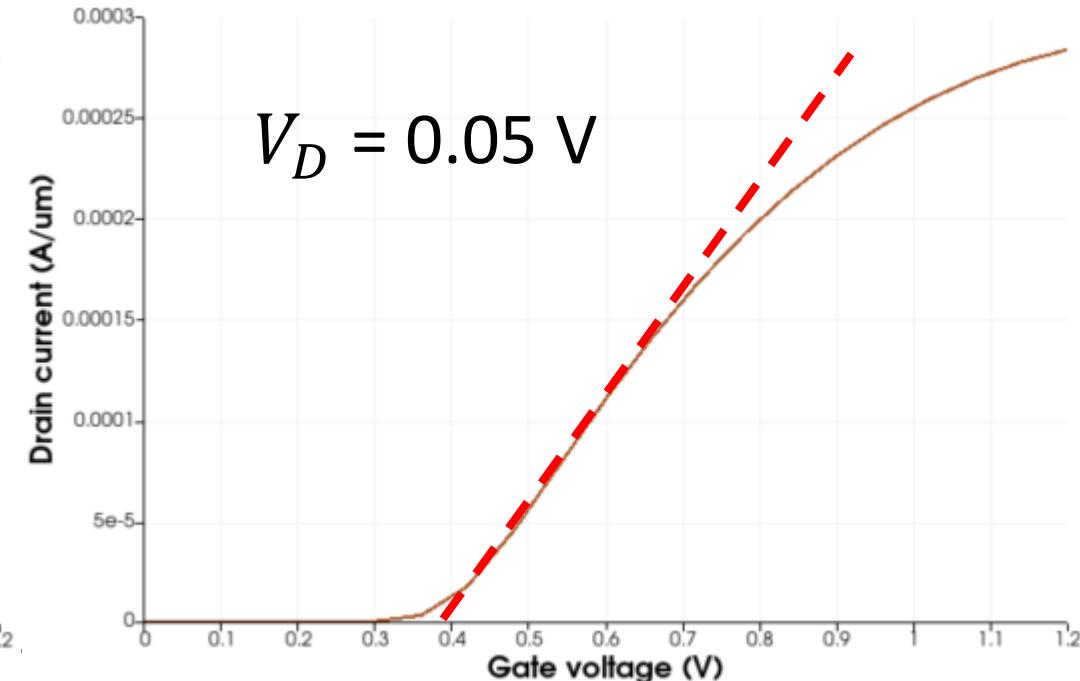
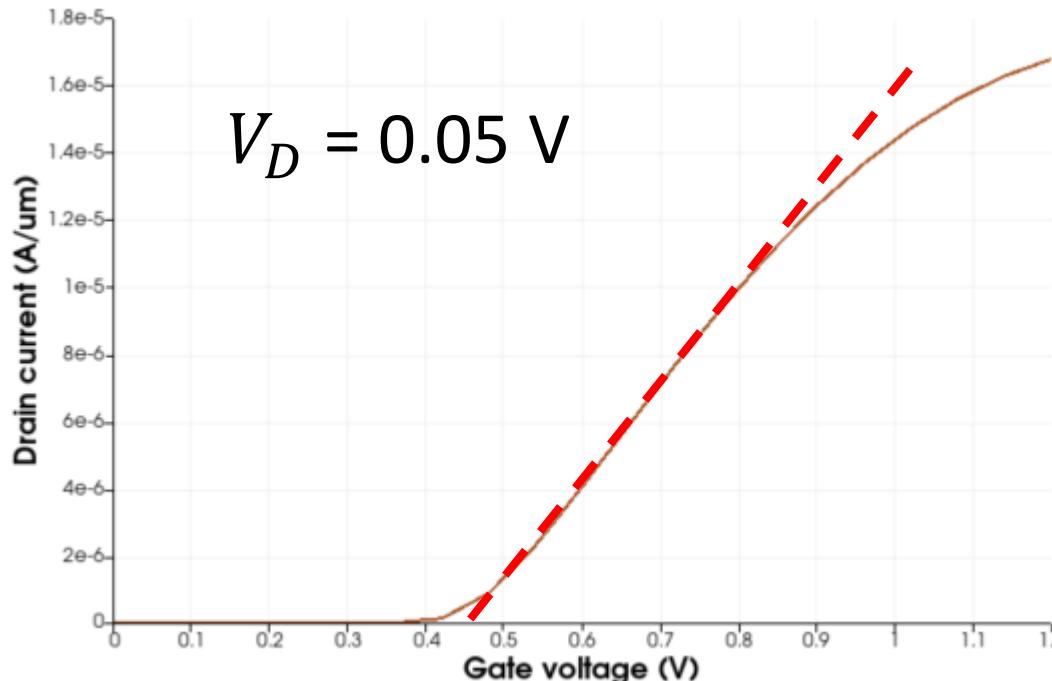
- Physical models included

- Note that $I_D \propto \frac{1}{L}$.



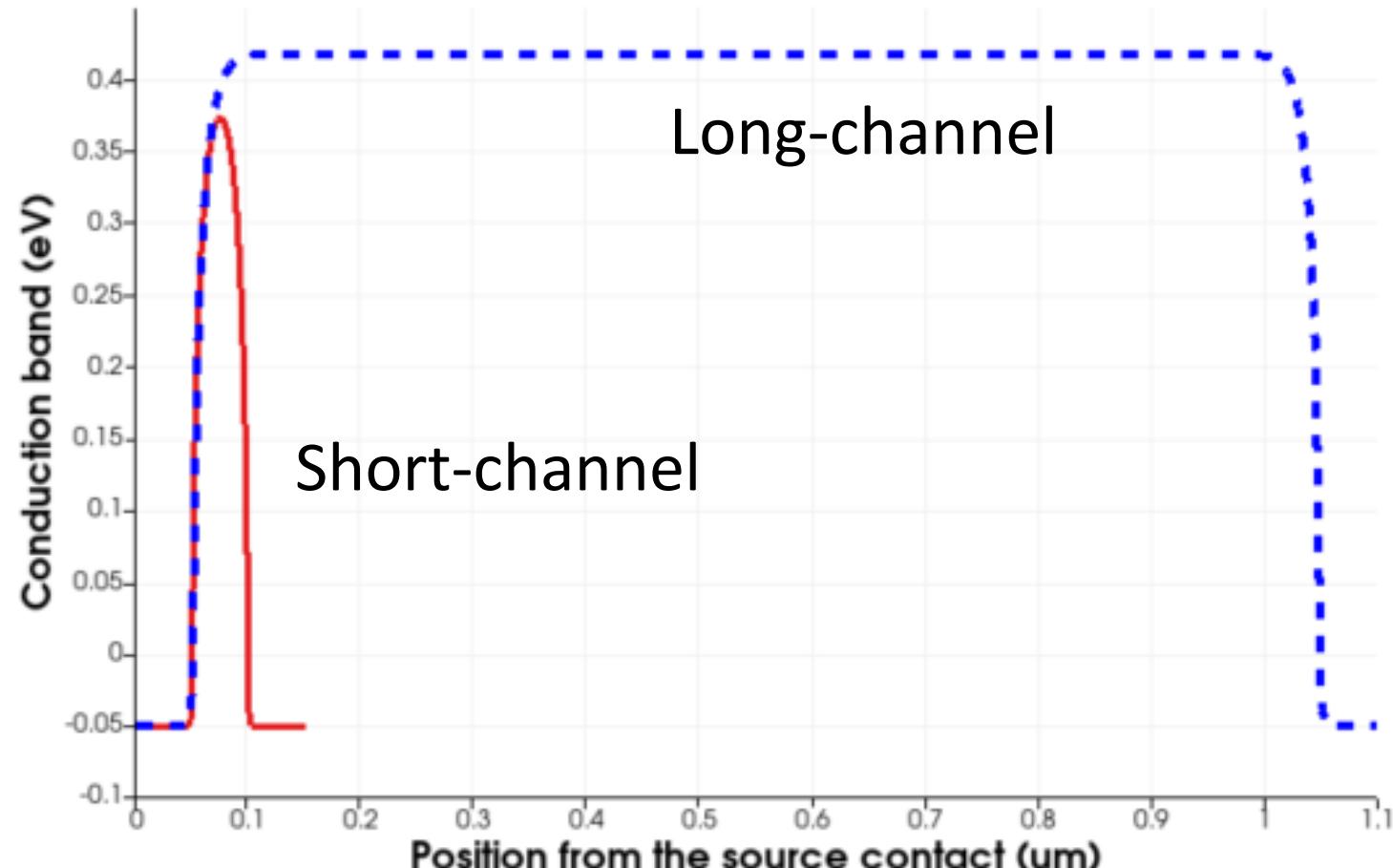
Reduction of V_{TH} , even at a low V_D

- For a short-channel device, the threshold voltage decreases.
 - ~ 0.45 V (Long-channel)
 - ~ 0.4 V (Short-channel)



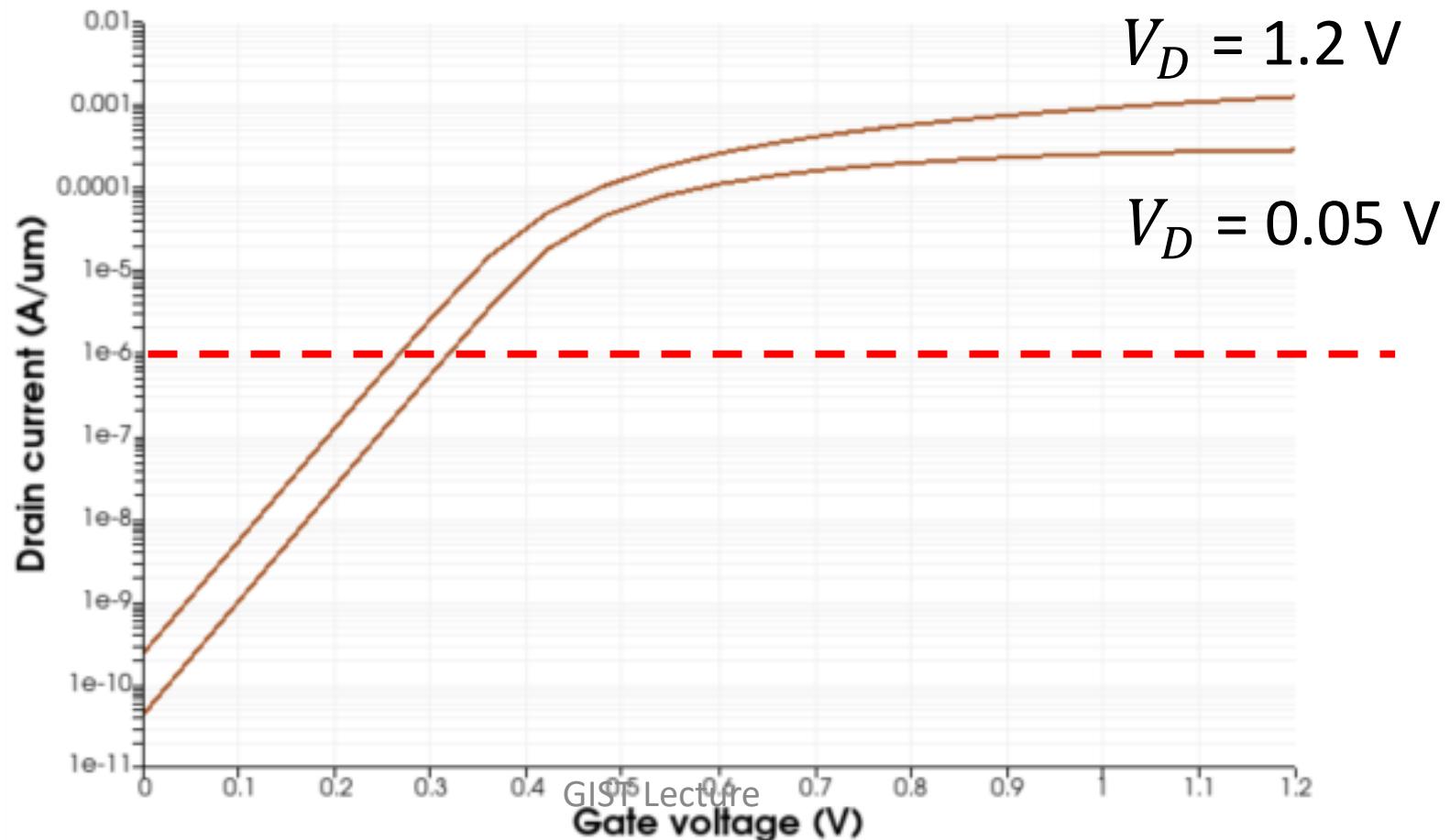
Charge sharing

- Even at $V_G = V_D = 0$ V, the conduction band profiles are different.



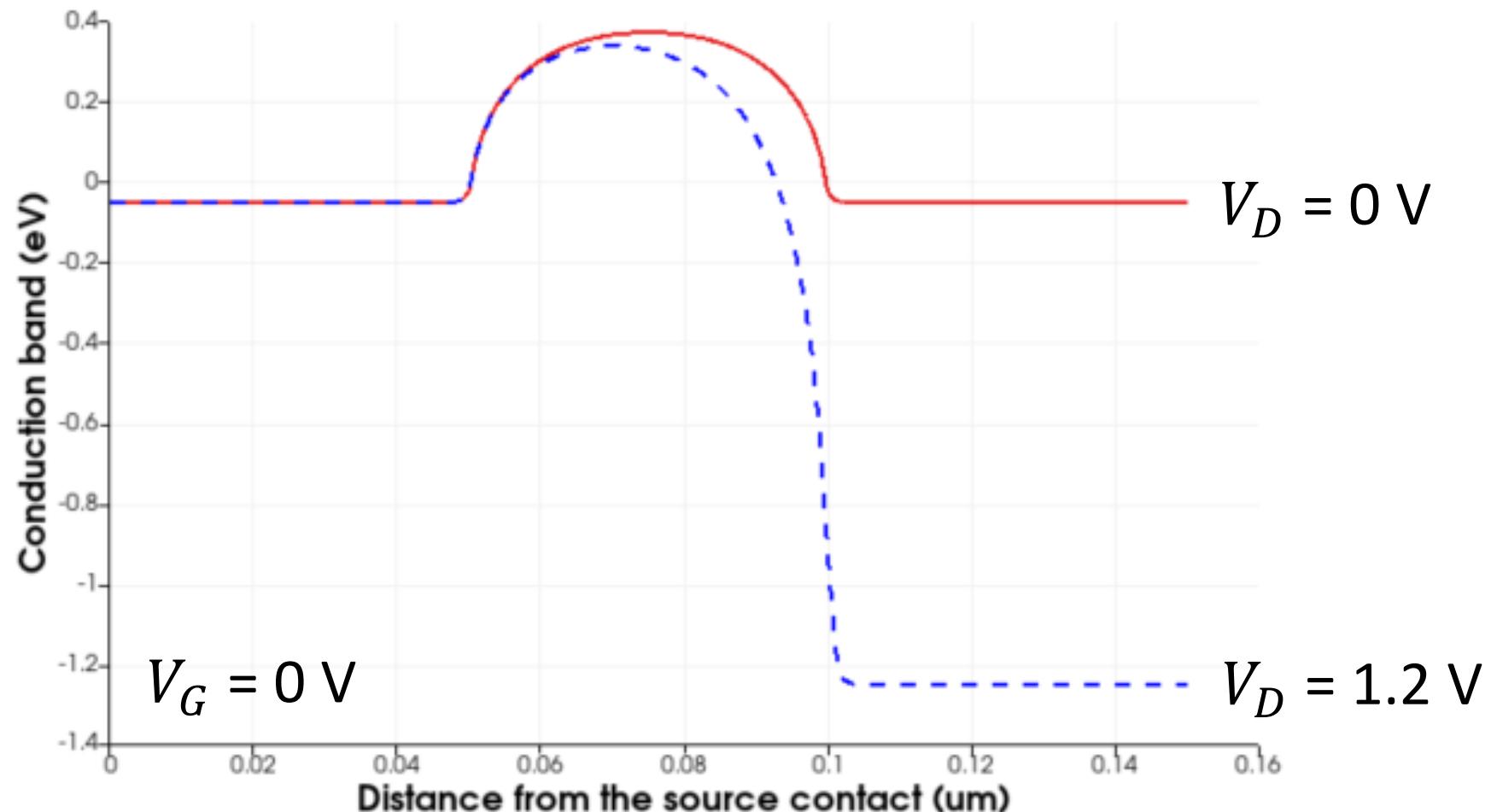
DIBL

- Much worse than the long-channel device
 - $-45 \text{ mV/V} @ I_D = 10^{-6} \text{ A}/\mu\text{m}$



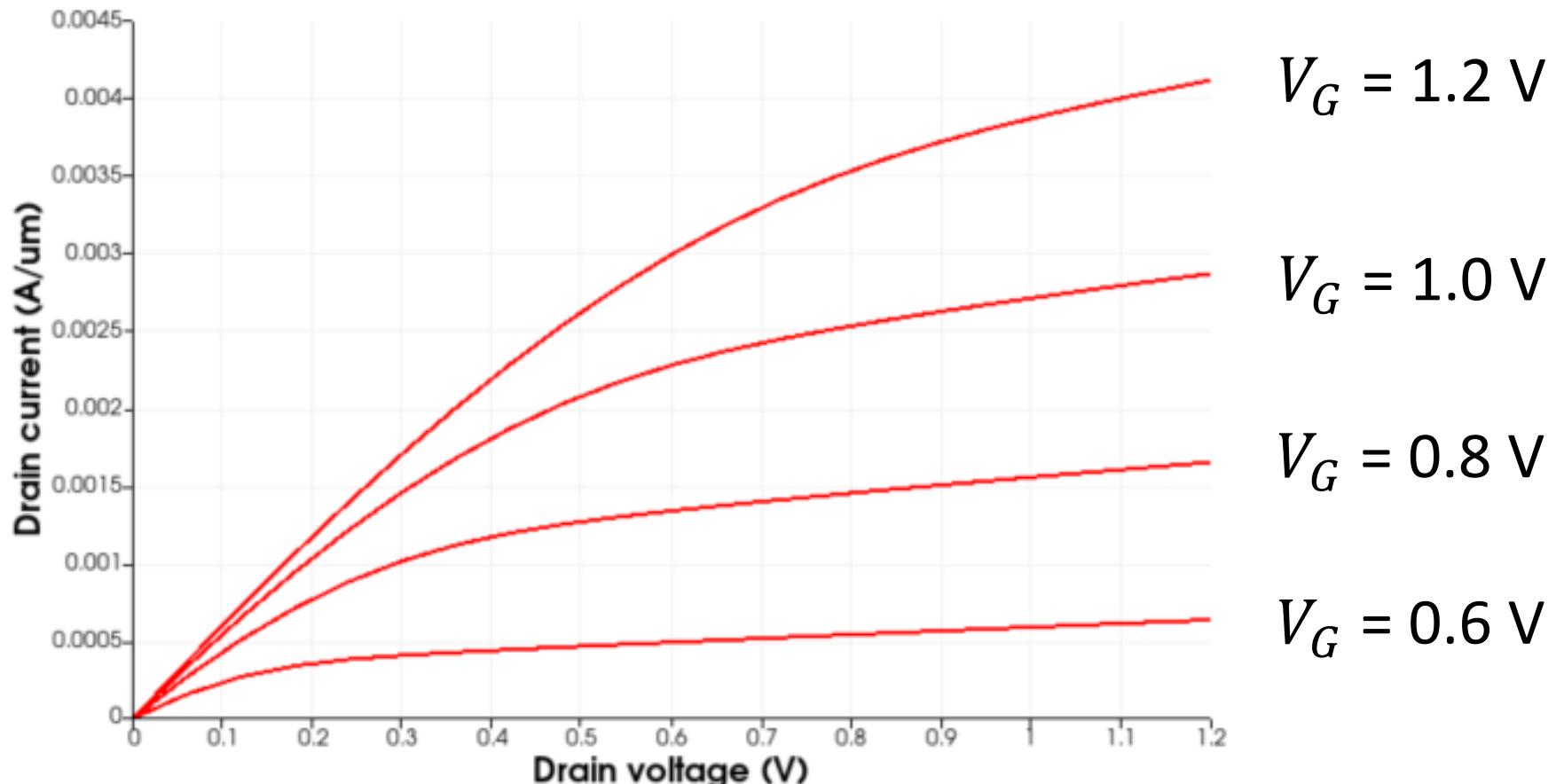
Conduction band

- At a high V_D , the energy barrier is further reduced.



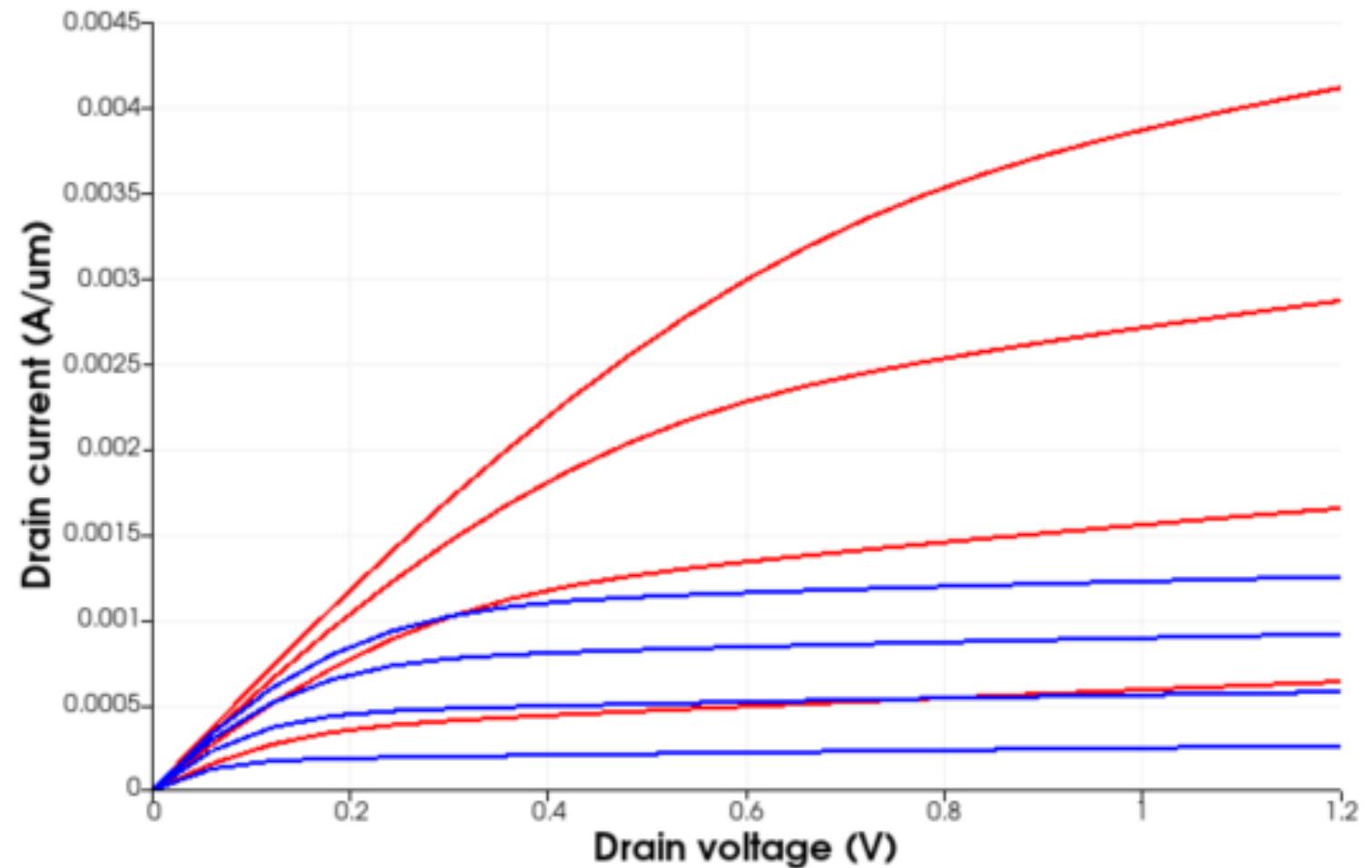
Channel-length modulation

- Results WITH inversion mobility model (No velocity saturation)



Velocity saturation

- Results WITH inversion mobility model + velocity saturation
 - Huge impact
 - Earlier saturation



Thank you!